



**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q77249

Takeshi HATTORI, et al.

Appln. No.: 10/656,363

Group Art Unit: 1751

Confirmation No.: 8238

Examiner: Unknown

Filed: September 8, 2003

For: METHOD OF PRODUCING INDIUM TIN OXIDE POWDER

**INFORMATION DISCLOSURE STATEMENT**  
**UNDER 37 C.F.R. §§ 1.97 and 1.98**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure under 37 C.F.R. § 1.56, Applicant hereby notifies the U.S. Patent and Trademark Office of the documents which are listed on the attached PTO/SB/08 A & B (modified) form and/or listed herein and which the Examiner may deem material to patentability of the claims of the above-identified application.

1. U.S. Patent No. 6,051,166, issued April 18, 2000, to Fujiwara et al.
2. U.S. Patent Application Publication No. 2002/0153521 A1, published October 24, 2002, to Hattori et al.
3. Japanese Laid-Open Patent Publication No. 2001-40434, published February 13, 2001, to Sumitomo Chemical Co., Ltd., with English Abstract.
4. Japanese Laid-Open Patent Publication No. 2000-281337, published October 10, 2000, to Sumitomo Chemical Co., Ltd., with English Abstract.
5. Japanese Laid-Open Patent Publication No. 2000-3618, published January 7, 2000, to Dowa Mining Co., Ltd., with English Abstract.
6. Japanese Laid-Open Patent Publication No. 7-247162, published September 26, 1995, to Mitsubishi Materials Corp., with English Abstract.

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INFORMATION DISCLOSURE STATEMENT

7. Japanese Laid-Open Patent Publication No. 7-21831, published January 24, 1995, to Mitsubishi Materials Corp., with English Abstract.
8. Japanese Laid-Open Patent Publication No. 62-7627, published January 14, 1987, to Showa Denko KK, with English Abstract.

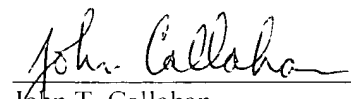
One copy of each of the listed documents, other than any U.S. patents and patent publications, is submitted herewith.

The present Information Disclosure Statement is being filed: (1) No later than three months from the application's filing date; (2) Before the mailing date of the first Office Action on the merits (whichever is later); or (3) Before the mailing date of the first Office Action after filing a request for continued examination (RCE) under §1.114, and therefore, no Statement under 37 C.F.R. § 1.97(e) or fee under 37 C.F.R. § 1.17(p) is required.

The submission of the listed documents is not intended as an admission that any such document constitutes prior art against the claims of the present application. Applicant does not waive any right to take any action that would be appropriate to antedate or otherwise remove any listed document as a competent reference against the claims of the present application.

The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account. A duplicate copy of this paper is attached.

Respectfully submitted,

  
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WASHINGTON OFFICE

**23373**

CUSTOMER NUMBER

Date: February 17, 2004

Substitute for Form 1449 A &amp; B/PTO

# **INFORMATION DISCLOSURE STATEMENT BY APPLICANT**

(use as many sheets as necessary)

Sheet

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of

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Complete if Known

Application Number	10/656,363
Confirmation Number	8238
Filing Date	September 8, 2003
First Named Inventor	Takeshi HATTORI
Art Unit	1751
Examiner Name	Unknown
Attorney Docket Number	Q77249

## **U.S. PATENT DOCUMENTS**

Examiner Initials*	Cite No. <sup>1</sup>	Document Number		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document
		Number	Kind Code <sup>2</sup> (if known)		
		US 6,051,166	A	04-18-2000	Fujiwara et al.
		US 2002/0153521	A1	10-24-2002	Hattori et al.
		US			
		US			
		US			
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## **FOREIGN PATENT DOCUMENTS**

Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document			Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Translation <sup>6</sup>
		Country Code <sup>3</sup>	Number <sup>4</sup>	Kind Code <sup>5</sup> (if known)			
		JP	2001-40434	A	02-13-2001	Sumitomo Chemical Co., Ltd.	Abstract
		JP	2000-281337	A	10-10-2000	Sumitomo Chemical Co., Ltd.	Abstract
		JP	2000-3618	A	01-07-2000	Dowa Mining Co., Ltd.	Abstract
		JP	07-247162	A	09-26-1995	Mitsubishi Materials Corp.	Abstract
		JP	07-21831	A	01-24-1995	Mitsubishi Materials Corp.	Abstract
		JP	62-7627	A	01-14-1987	Showa Denko KK	Abstract

## **NON PATENT LITERATURE DOCUMENTS**

Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city, and/or country where published.	Translation <sup>6</sup>

Examiner Signature	Date Considered
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>1</sup>Applicant's unique citation designation number (optional). <sup>2</sup>See Kind Codes of USPTO Patent Documents at [www.uspto.gov](http://www.uspto.gov), MPEP 901.04 or in the comment box of this document. <sup>3</sup>Enter Office that issued the document, by the two-letter code (WIPO Standard ST. 3). <sup>4</sup>For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup>Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>6</sup>Applicant is to indicate here if English language Translation is attached.